It is my sincere gratitude as President of SICE, Japanese sister society of ICROS that the President of ICROS kindly invited me to ICCAS 2020. It is also my great honor to deliver a message for the International Conference on control, automation, and systems.

It is well known that ICROS has contributed a lot to the development and establishment of control, automation, and systems technologies and international collaboration with Asian countries as well as over the world. I would like to congratulate you on the success of ICCAS, one of the most important worldwide conferences on control, automation, and systems.

I am deeply impressed by a lot of things ICROS has ever achieved, for example, international journal publication. It is my pleasure that many Japanese researchers and engineers have attended and enjoyed ICCAS. I hope that such a collaborative relationship is developed further.

We suffer the severe pandemic of COVID-19 this year all over the world. ICCAS 2020 has been decided to be held online for safety. I suppose that it must have been a great challenge for ICROS to take such a decision while International SICE Annual Conference 2020 was also held online last September. I hope that ICCAS 2020 and SICE 2020 will open a new style of international online conferences for the future.

I would like to offer sincere congratulations on the successful and well organized ICCAS 2020.

Akira Ono, Dr.
President of Society of Instrumentation and Control Engineers (SICE)
Personal History of Akira ONO

Academic and technical background

Dr. Akira Ono graduated Physics Department, the University of Tokyo in 1969 and then the Graduate School of Physics of the same University in 1974. He received Doctoral Degree of Science from the University of Tokyo in solid state physics.

He joined former National Research Laboratory of Metrology (NRLM), AIST (National Institute of Advanced Industrial Science and Technology) in 1974. His work had been in measurement standards and application of radiation thermometry, remote sensing and measurement technology and reference materials for thermophysical properties of solids. He joined as a guest researcher Thermophysical Properties Research Laboratory, Purdue University, USA for 1981 and 1982.

Appointed in 2001 Director of National Metrology Institute of Japan (NMIJ), AIST covering the Japanese national measurement standards and legal metrology. He was Vice President of AIST from 2006 to 2008, Senior Vice President of AIST from 2008 to 2012, and is now Special Advisor for AIST.

International activities

He was Head of the Japanese Delegates to General Conference of Weights and Measures (CGPM) of Meter Convention and to Asia Pacific Metrology Program (APMP) in early 2000’s, and the Japanese representative to Consultative Committee of Thermometry (CCT), International Committee of Weights and Measures (CIPM) in late 1990’s.

He was Head of Japanese delegates to ISO/TC229 Nanotechnologies from 2005 to 2015 and has been Chair of IEC/TC113 Nanotechnology for Electrotechnical Products and Systems since 2016.

He is now President of Society of Instrumentation and Control Engineers (SICE).